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| INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary) | | Application Number | |
| | | Filing Date | |
| | | First Named Inventor | Qi-Jun Zhao |
| | | Art Unit | |
| | | Examiner Name | |
| Sheet 1 of 1 | Attorney Docket Number | | |

| U.S. PATENT DOCUMENTS | | | | | |
|-----------------------|-----------------------|--------------------------------------------|--------------------------------|----------------------------------------------------|---------------------------------------------------------------------------------|
| Examiner Initials* | Cite No. ¹ | Document Number | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear |
| | | Number - Kind Code ² (if known) | | | |
| H A | | US- 5,603,625 | 02-18-1997 | Tondreault | FIG. 3 |
| | | US- 5,634,803 | 06-03-1997 | Cheng et al. | FIG. 2 |
| | | US- 5,662,485 | 09-02-1997 | Yip et al. | FIG. 9 |
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| FOREIGN PATENT DOCUMENTS | | | | | | | |
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| Examiner Initials* | Cite No. ¹ | Foreign Patent Document | | Publication Date MM-DD-YYYY | Name of Patentee or Applicant of Cited Document | Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear | T ⁶ |
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| Examiner Signature | <i>Him Lin</i> | Date Considered | 7/15/04 |
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¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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